

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideto Ohnuma et al.                      Art Unit : 2812  
Serial No. : 09/925,512                                      Examiner : Richard A. Booth  
Filed : August 10, 2001                                      Conf. No. : 4989  
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF AUGUST 8, 2006

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.